

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Takenori GOTO**

Serial No.: **Not Yet Assigned**

Filed: **June 26, 2001**

For: **NITRIDE BASED SEMICONDUCTOR LASER DEVICE AND METHOD OF
FABRICATING THE SAME**

JC997 U.S. PTO
09/888419
06/26/01

#3 / 153
11-21-01
R. Stokes

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231

June 26, 2001

Sir:

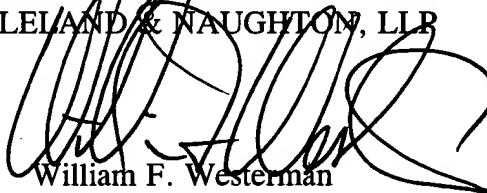
In compliance with 37 CFR 1.56, Applicant calls to the attention of the Patent and Trademark Office the reference listed on the attached PTO-1449.

A copy of the reference is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge

Deposit Account No. 01-2340.

Respectfully submitted,
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Enclosures: PTO-1449; References (1)